

FIG. 1

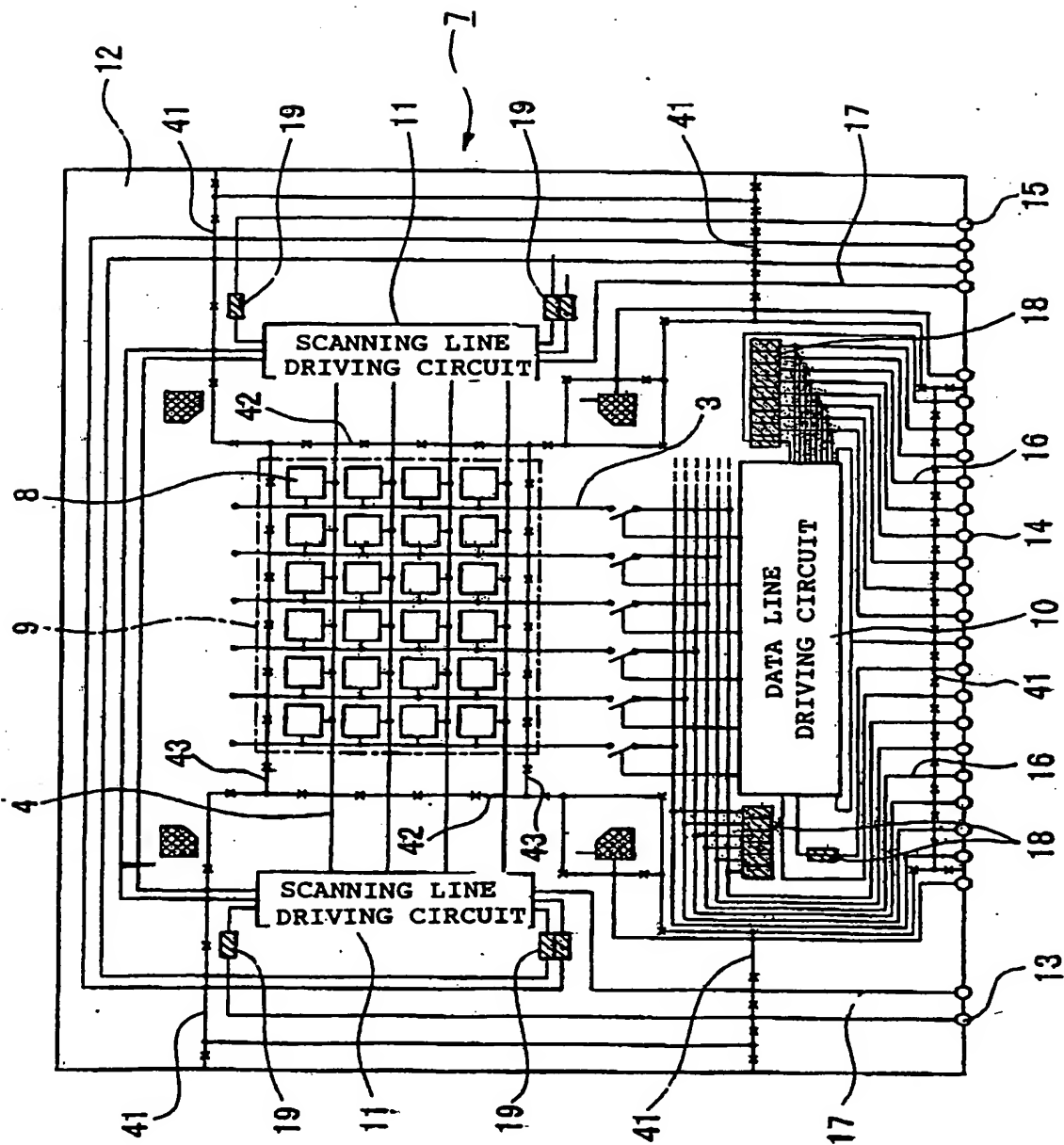


FIG. 2

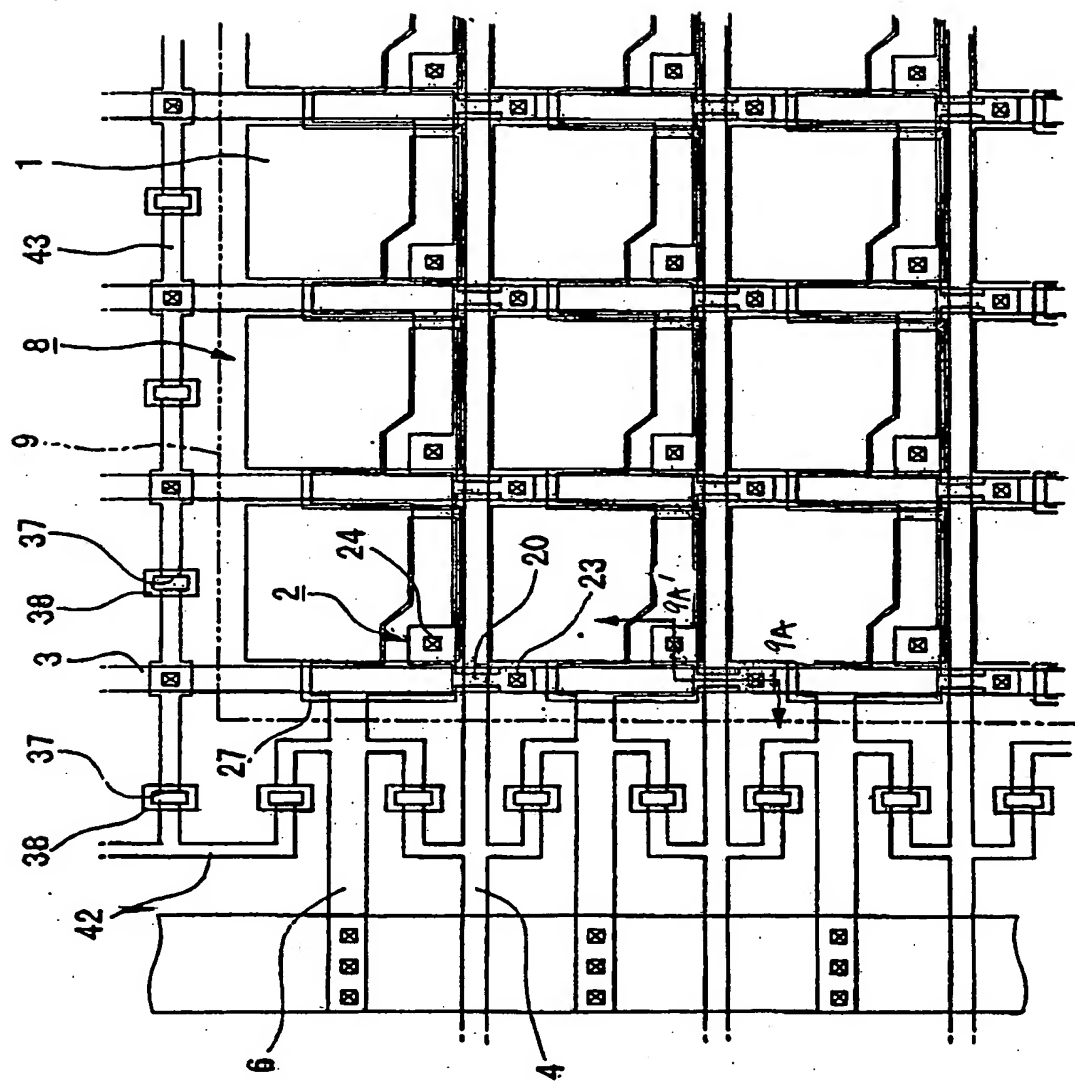


FIG. 3

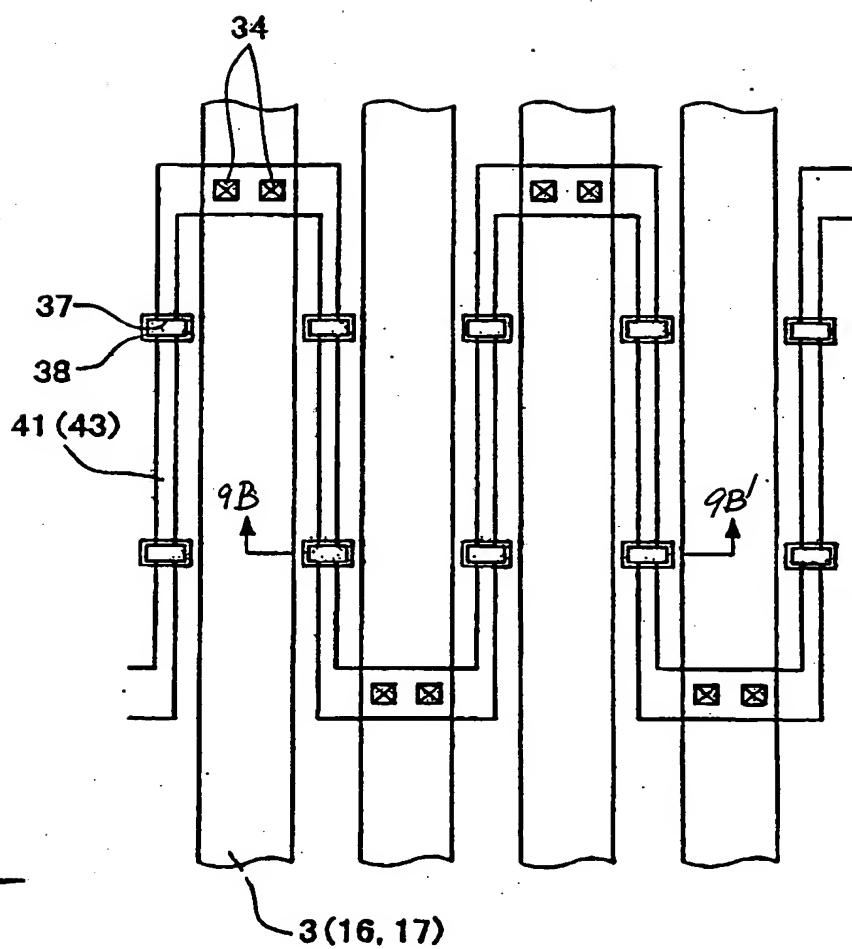


FIG. 4

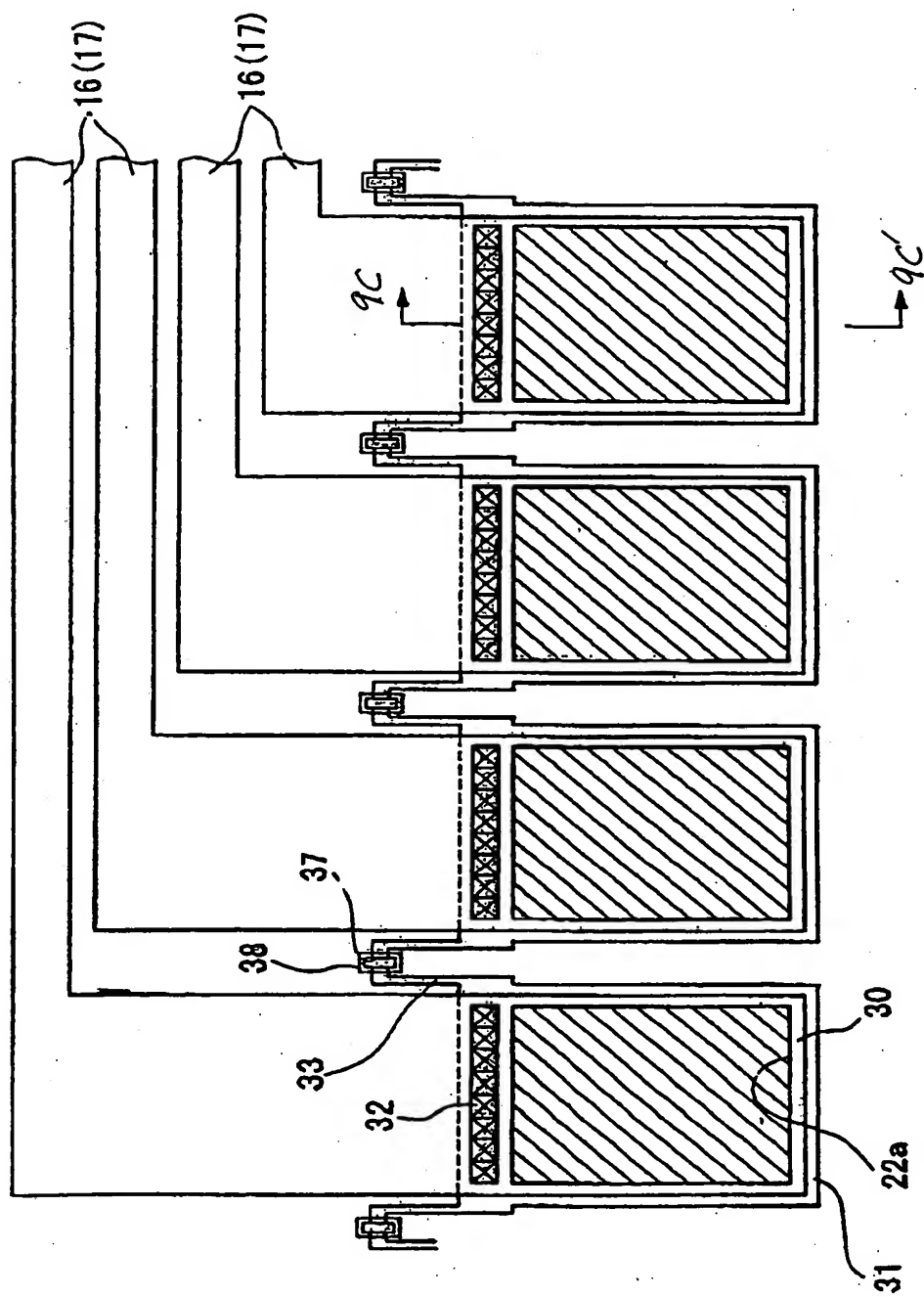


FIG. 5

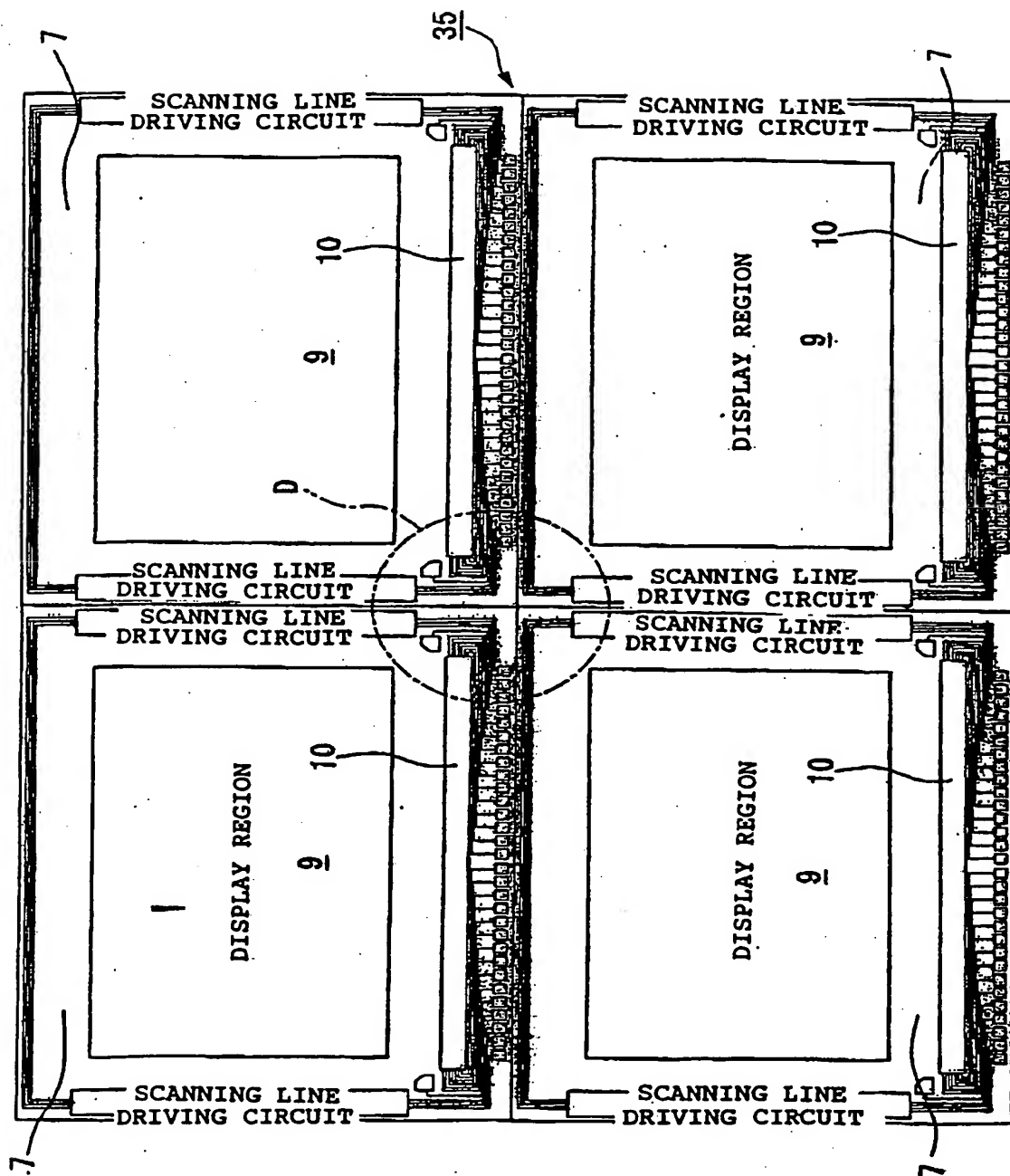


FIG. 6

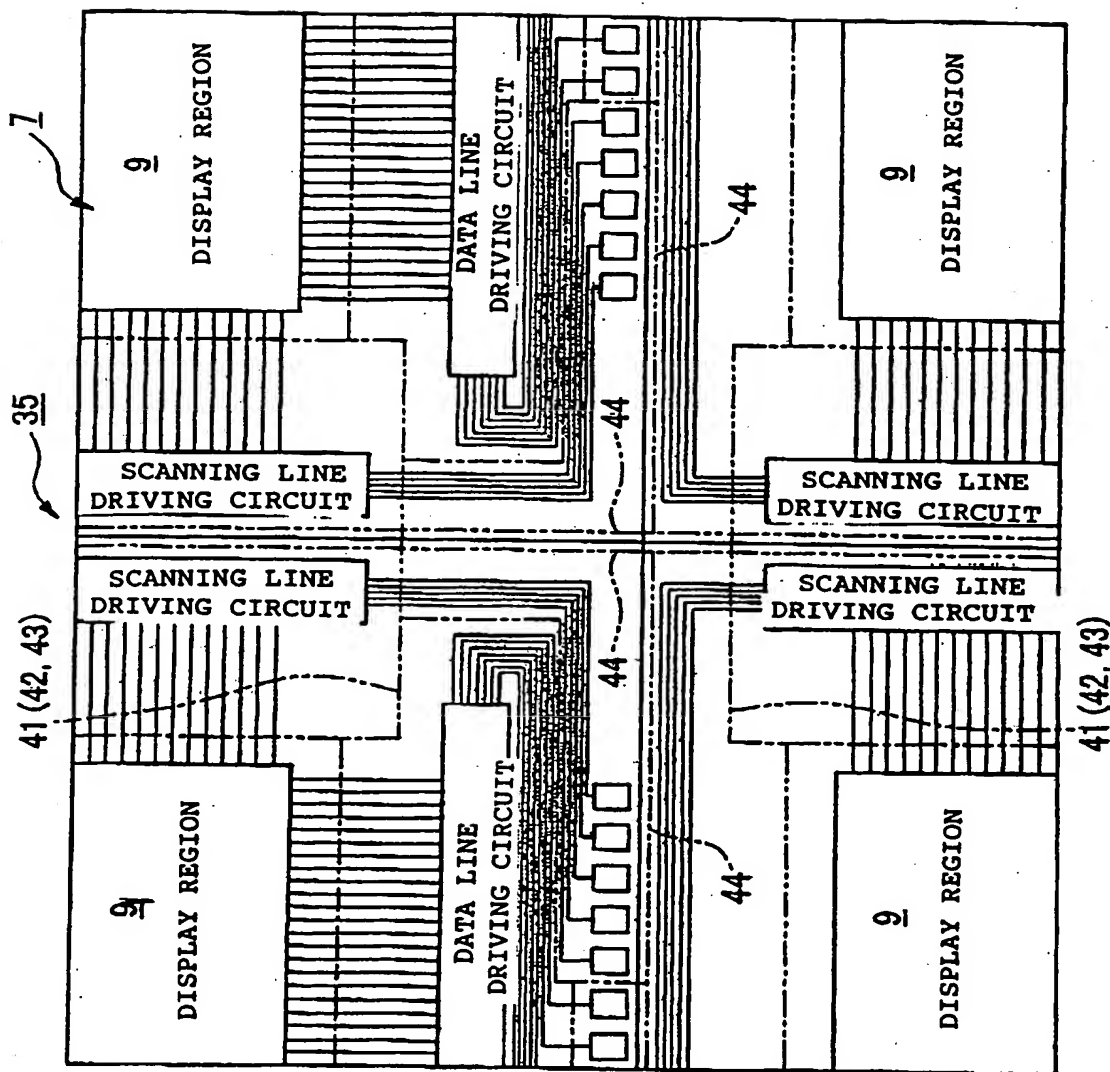
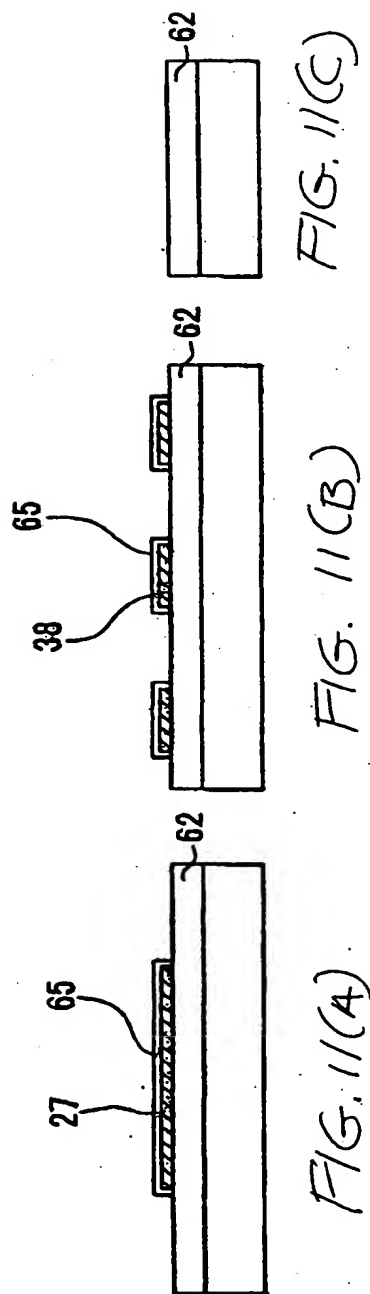
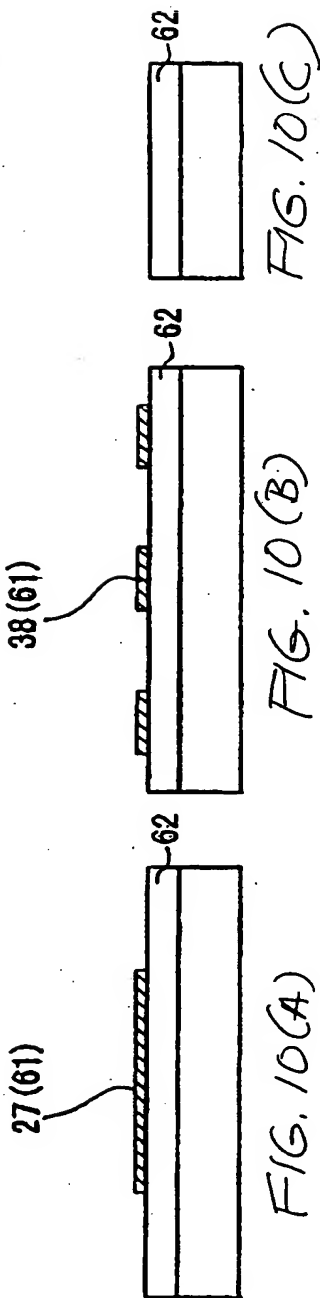
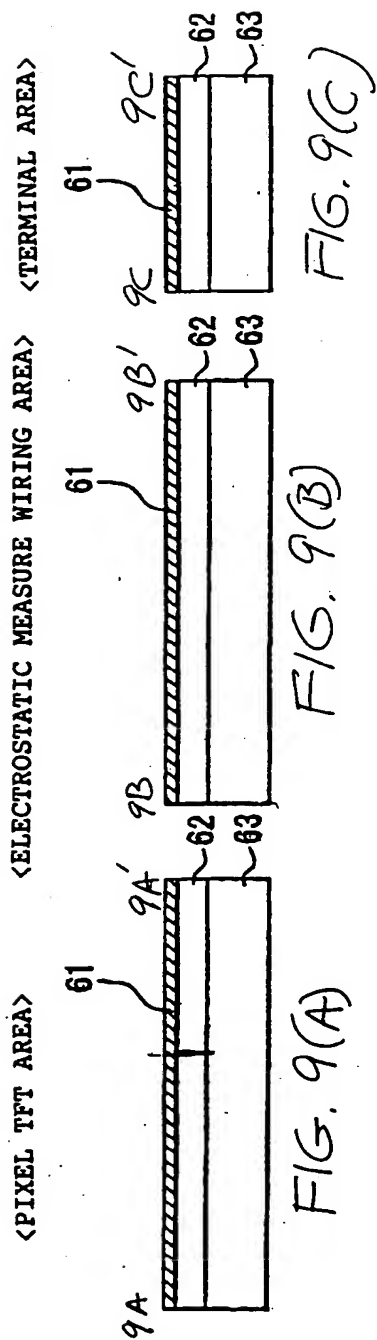
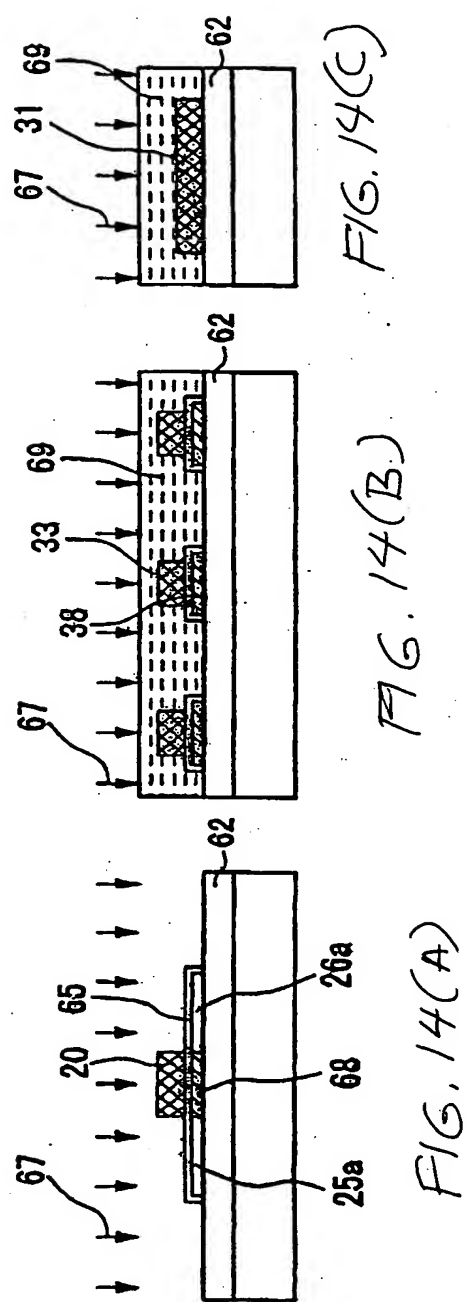
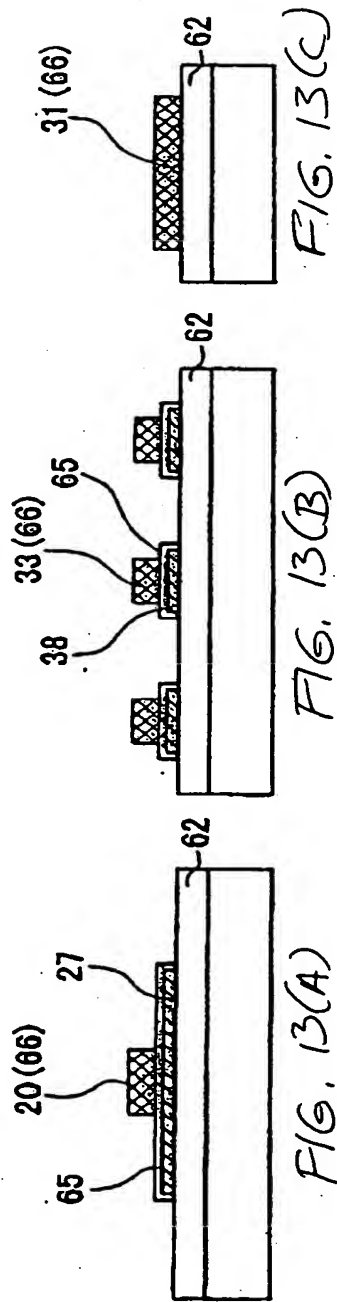
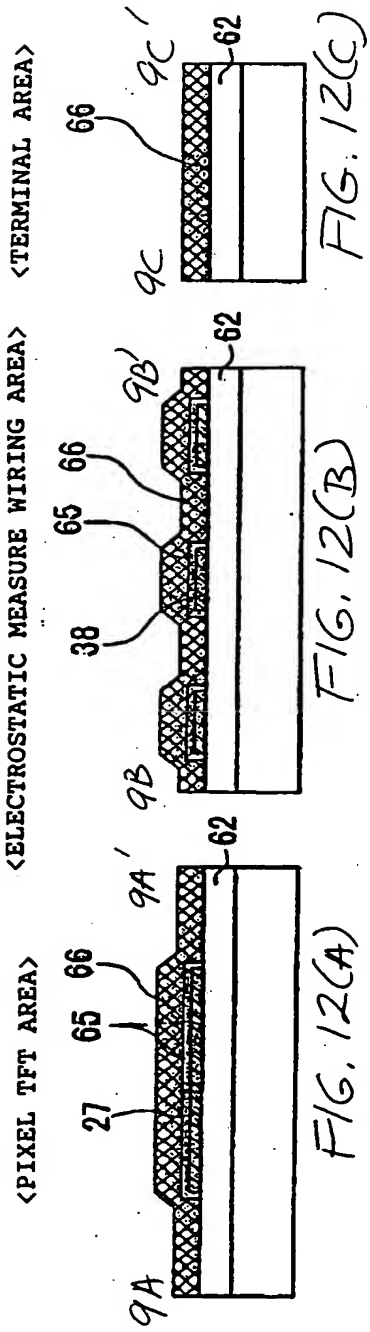


FIG. 7





< PIXEL TFT AREA > < ELECTROSTATIC MEASURE WIRING AREA > < TERMINAL AREA >

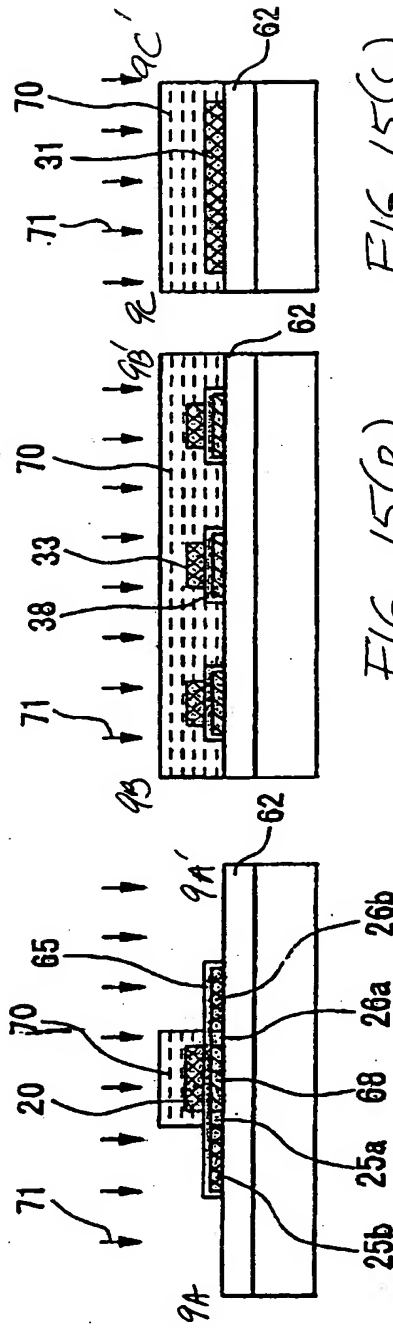


FIG. 15(B)

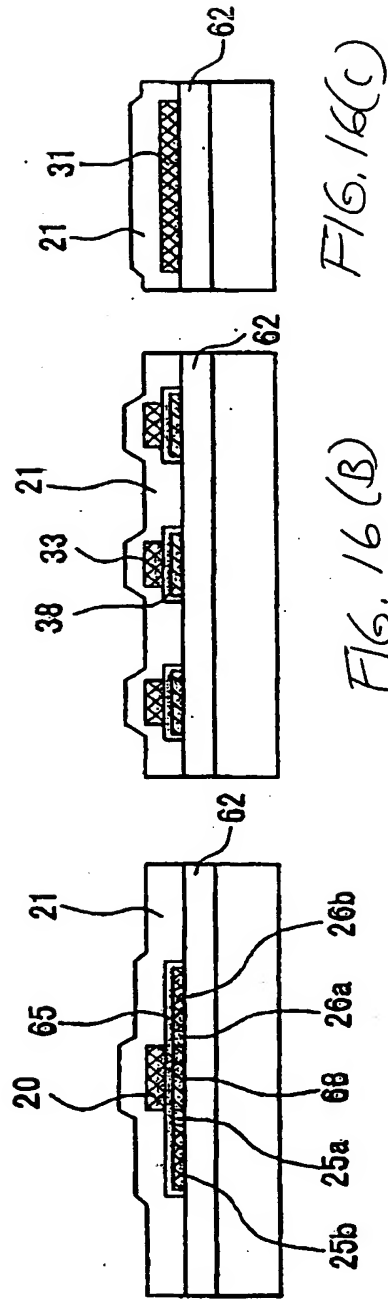
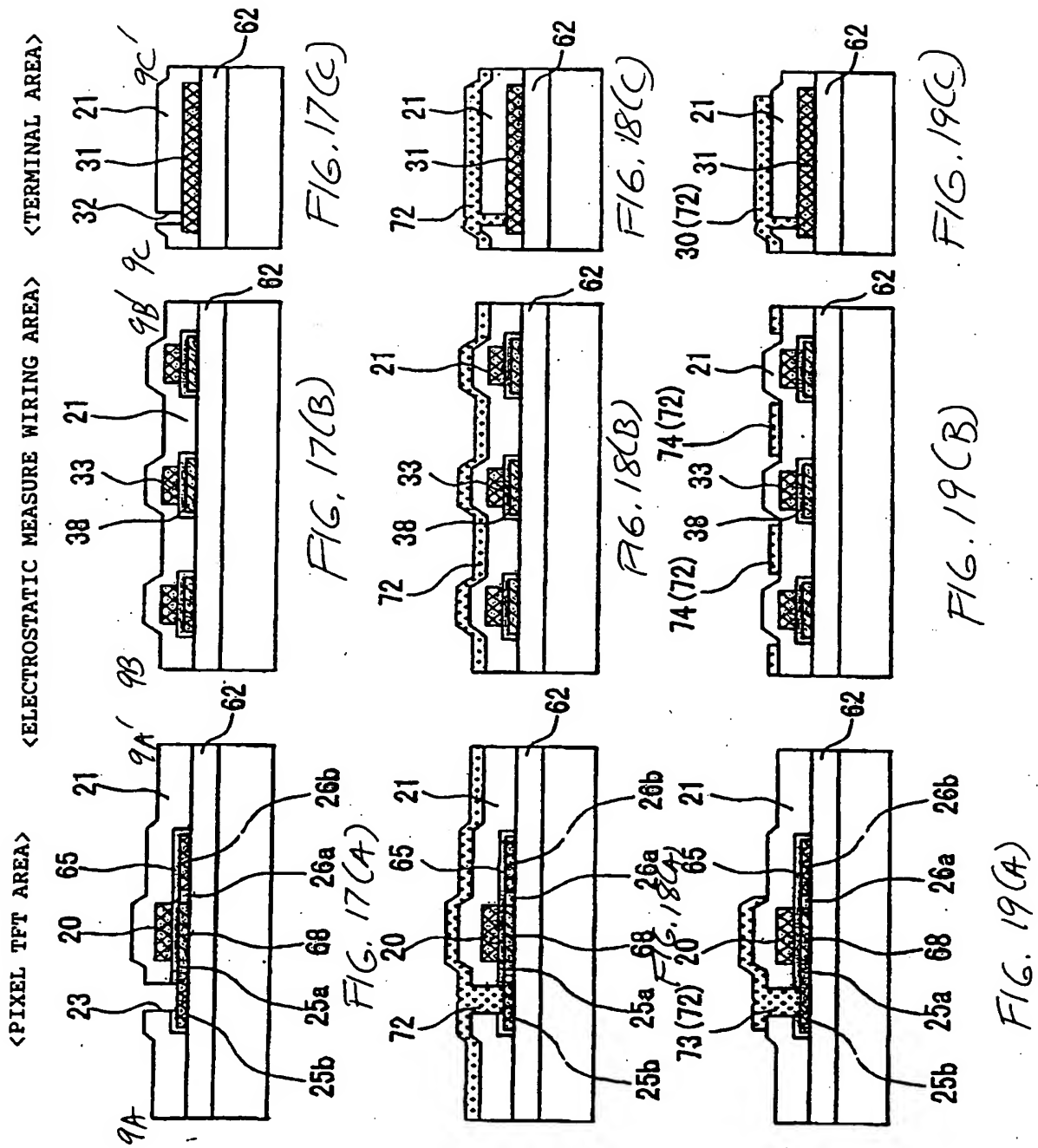
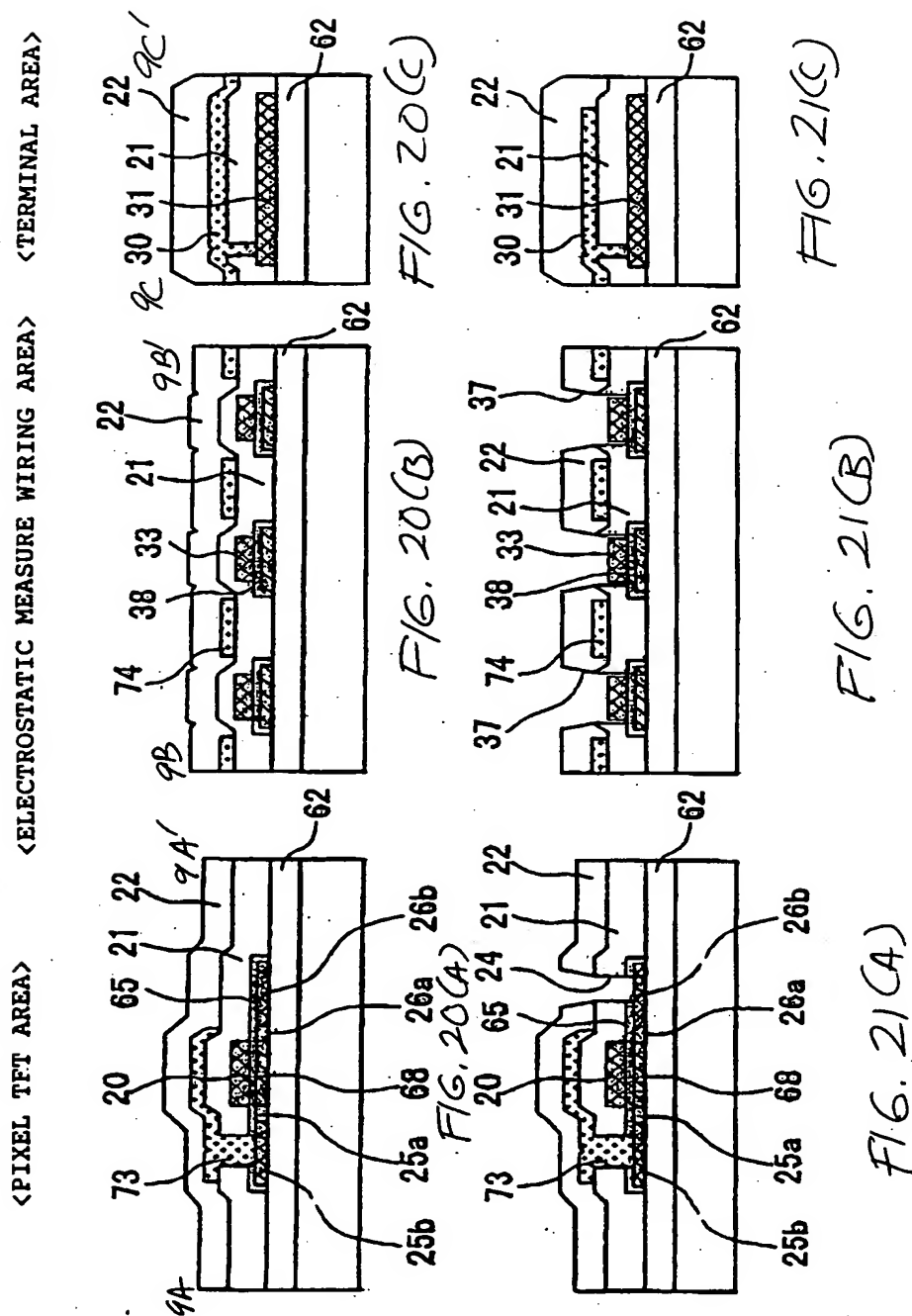


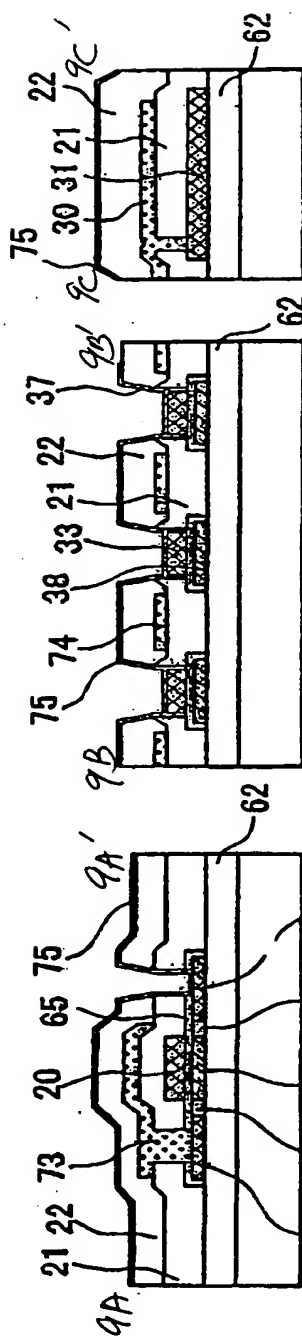
FIG. 16(A)

FIG. 16(B)





<PIXEL TFT AREA> <ELECTROSTATIC MEASURE WIRING AREA> <TERMINAL AREA>



<PIXEL TFT AREA> <ELECTROSTATIC MEASURE WIRING AREA> <TERMINAL AREA>

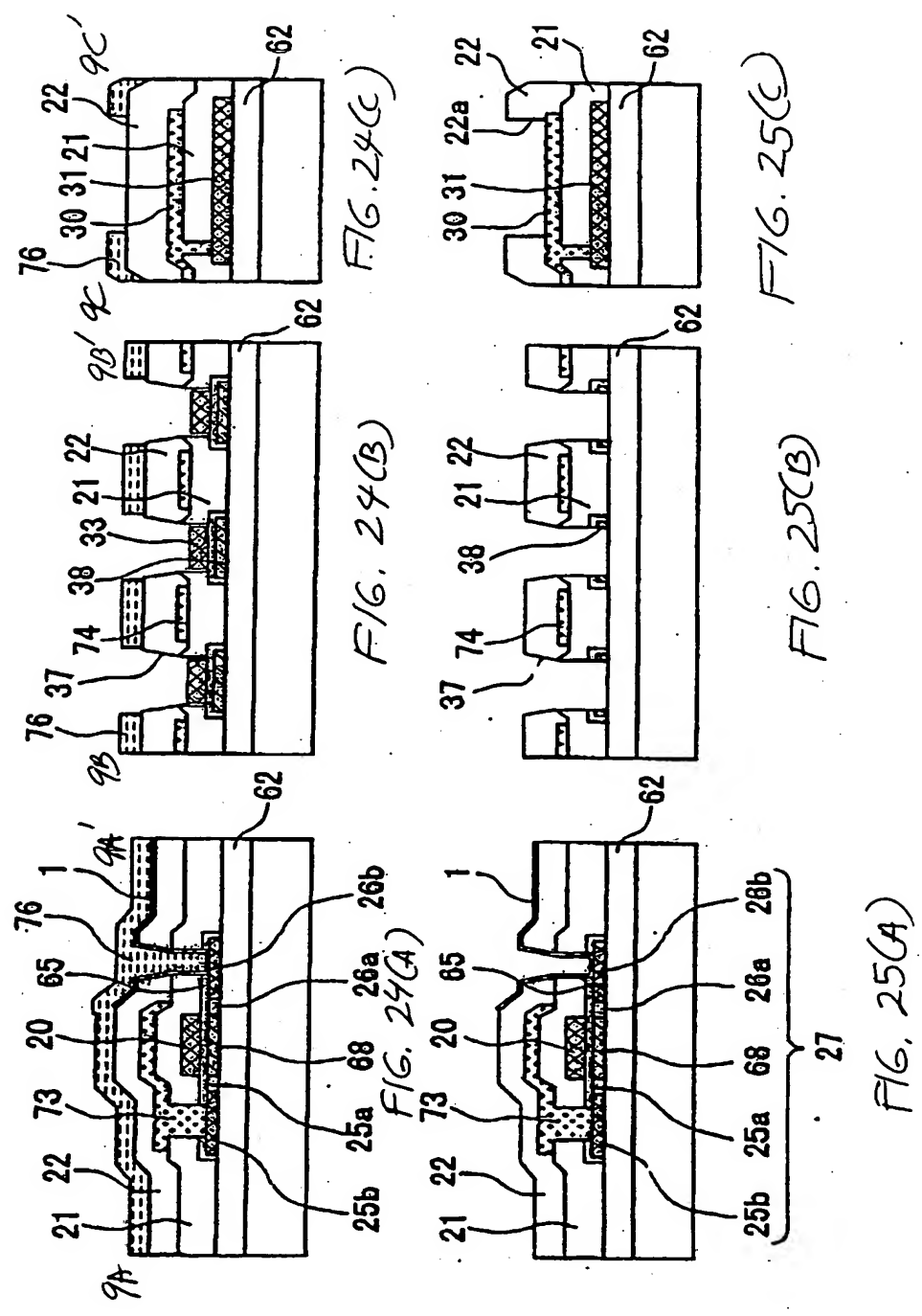


FIG. 25(A)

FIG. 25(B)

FIG. 24(C)

FIG. 24(B)

FIG. 24(A)

1

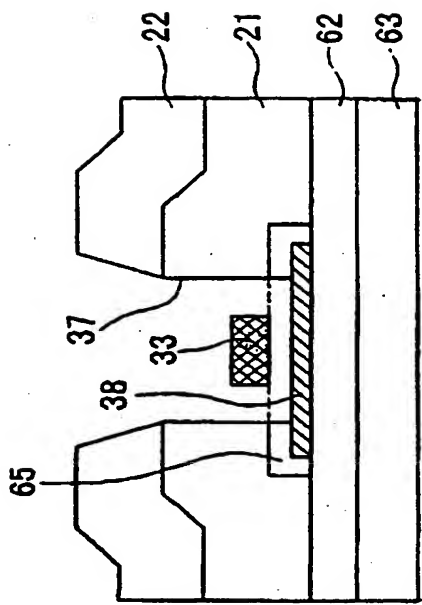


FIG. 26(B)

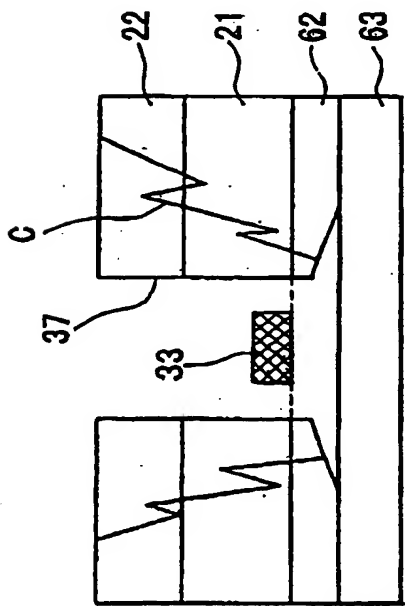


FIG. 26(A)

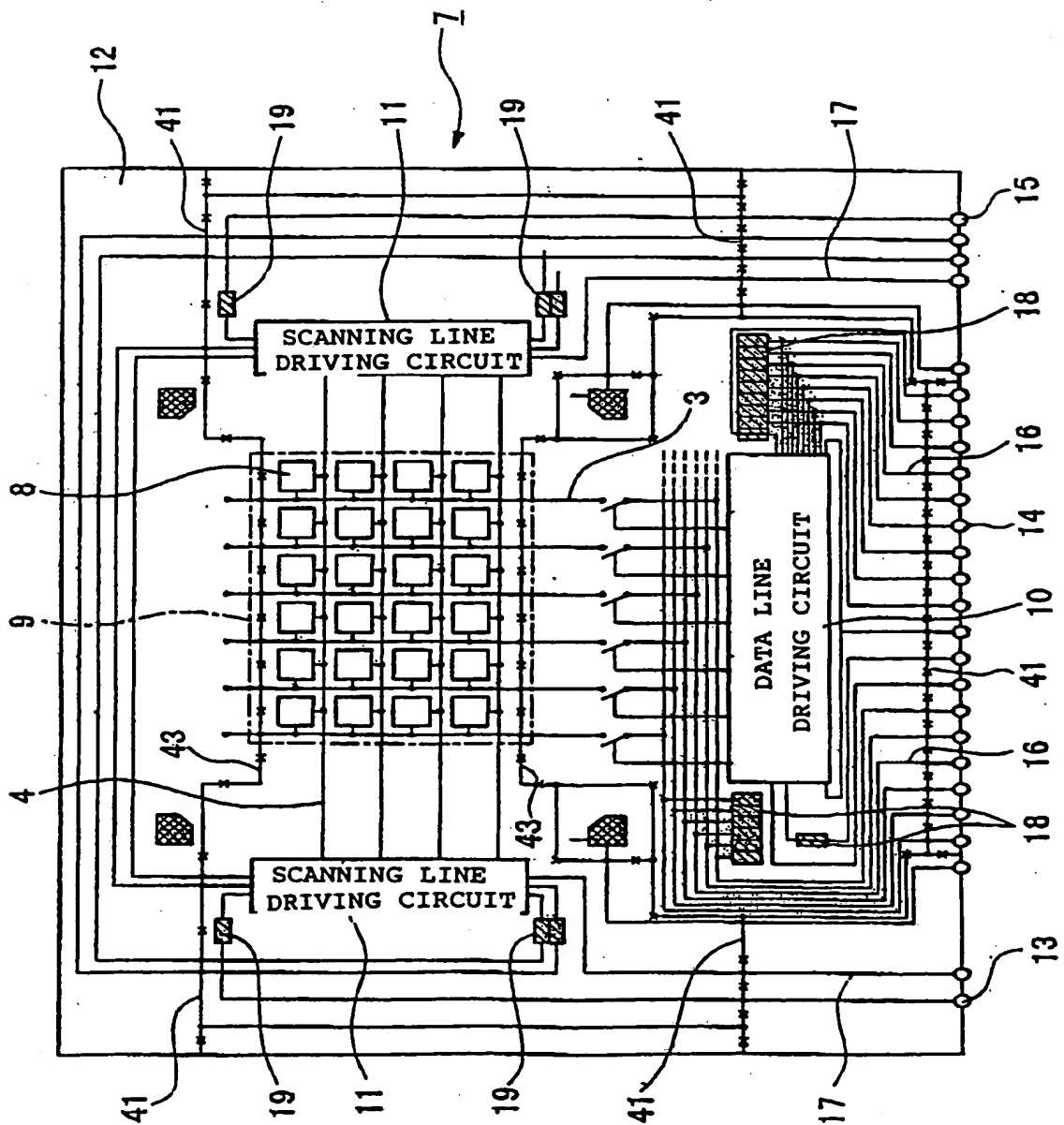


FIG. 27

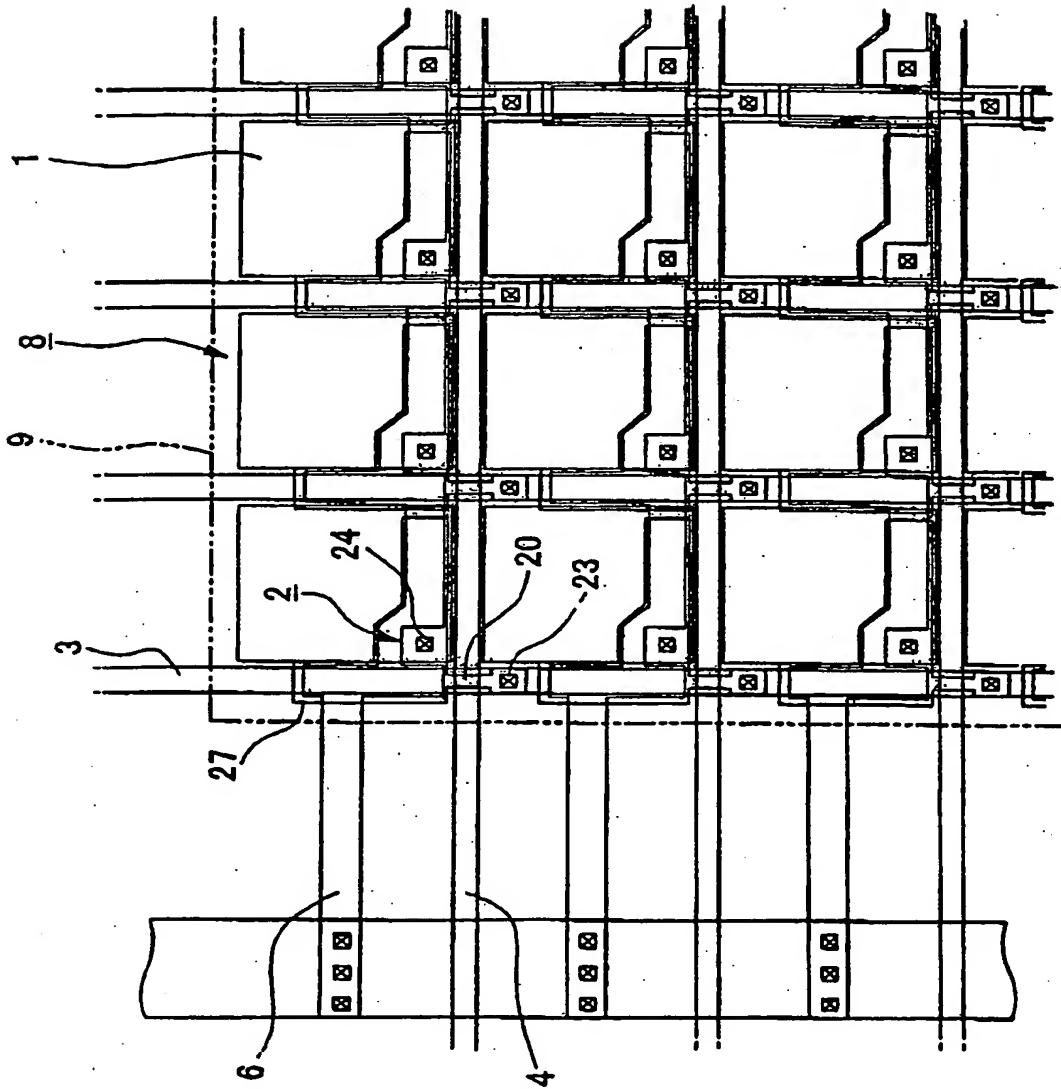


FIG. 28

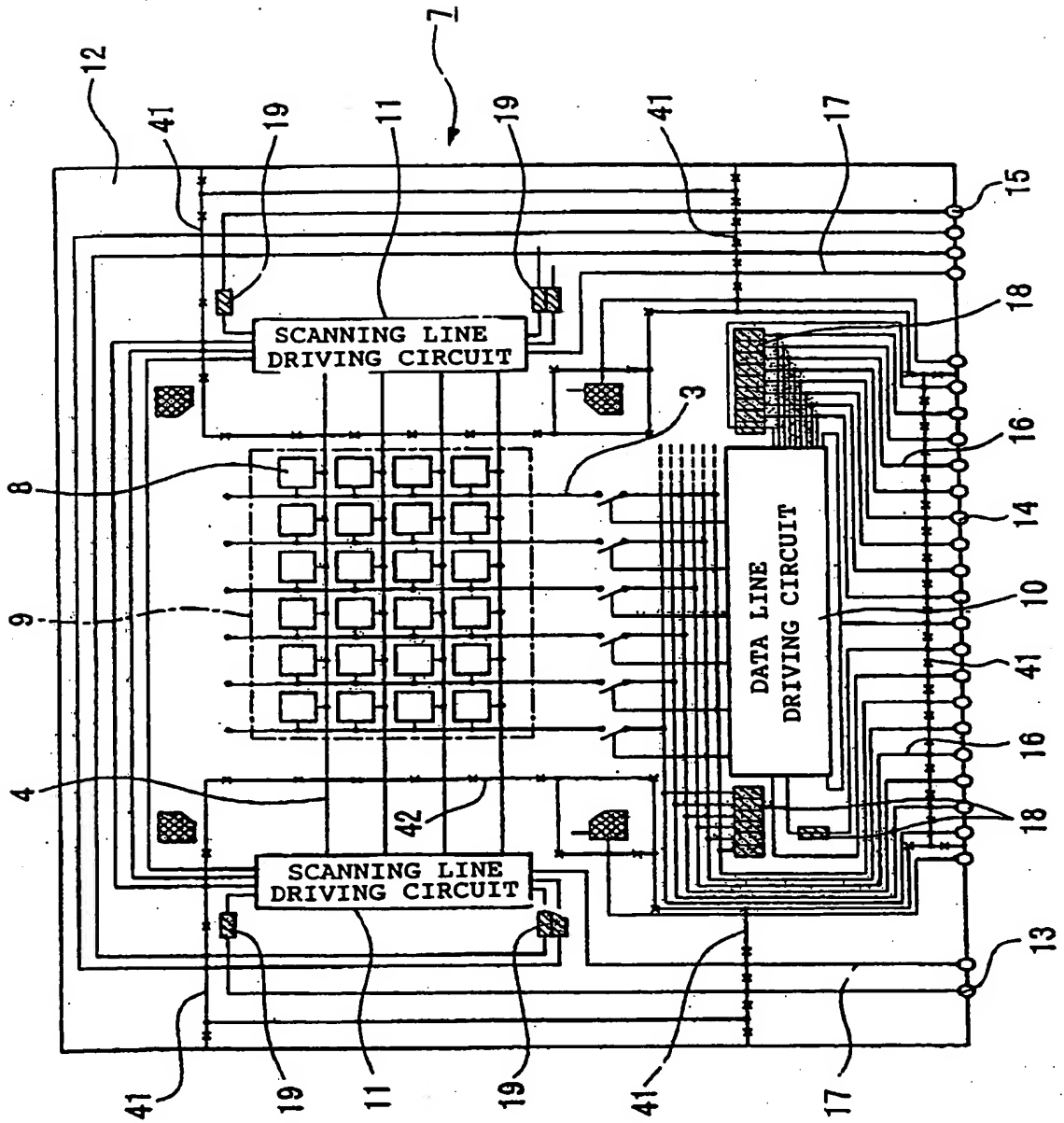


FIG. 29

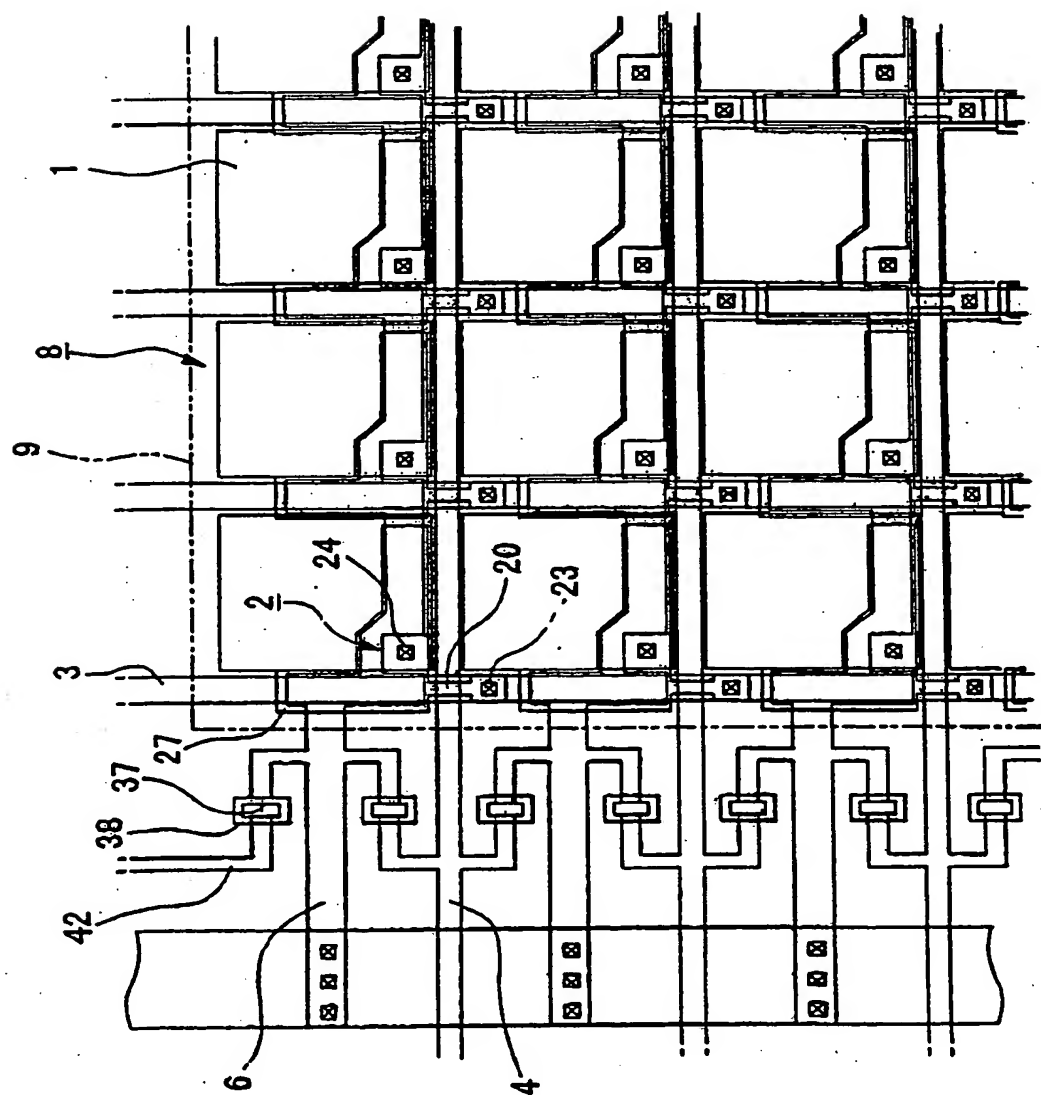


FIG. 36

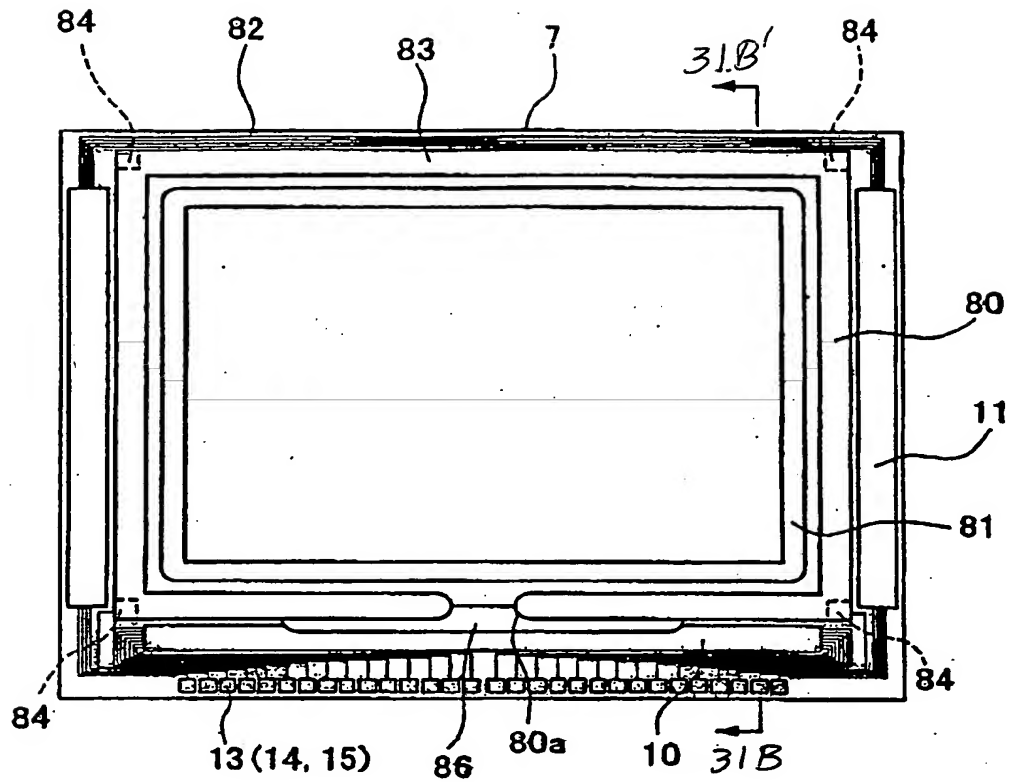


FIG. 31(A)

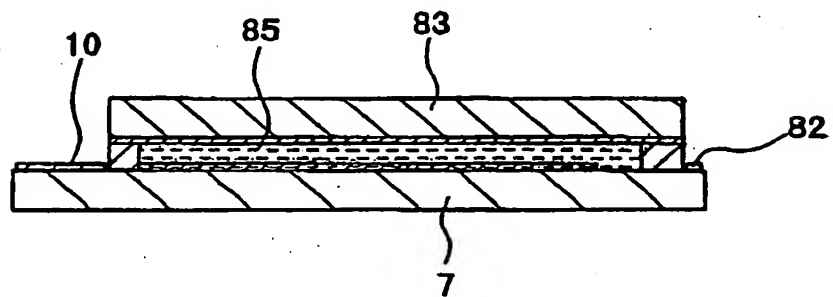


FIG. 31(B)

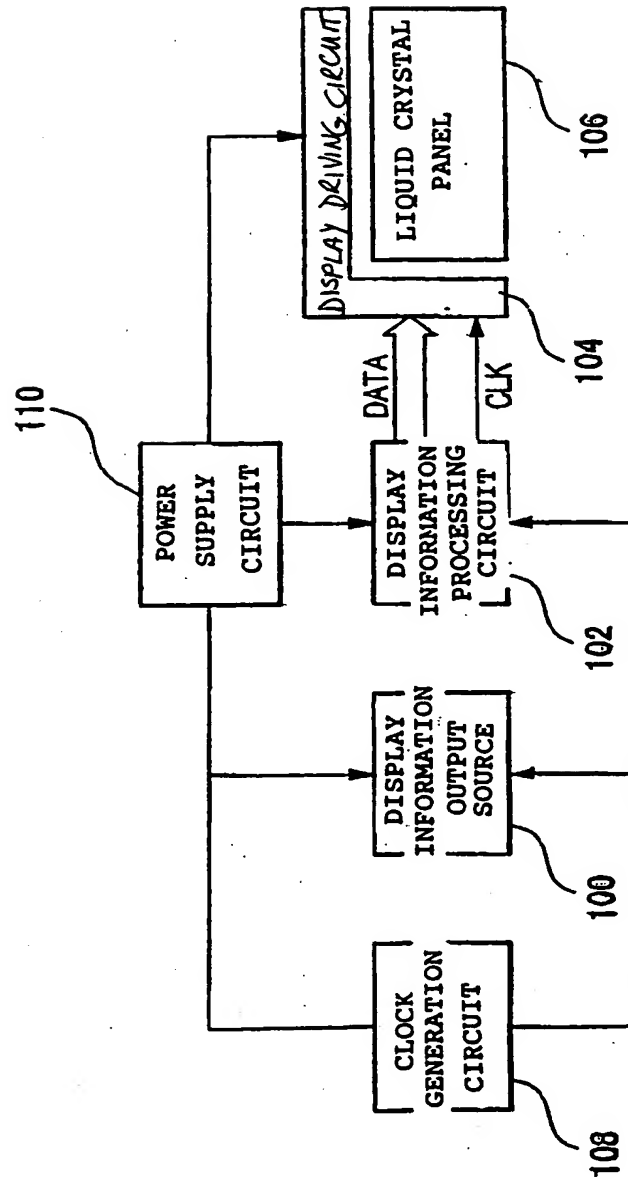


FIG. 32

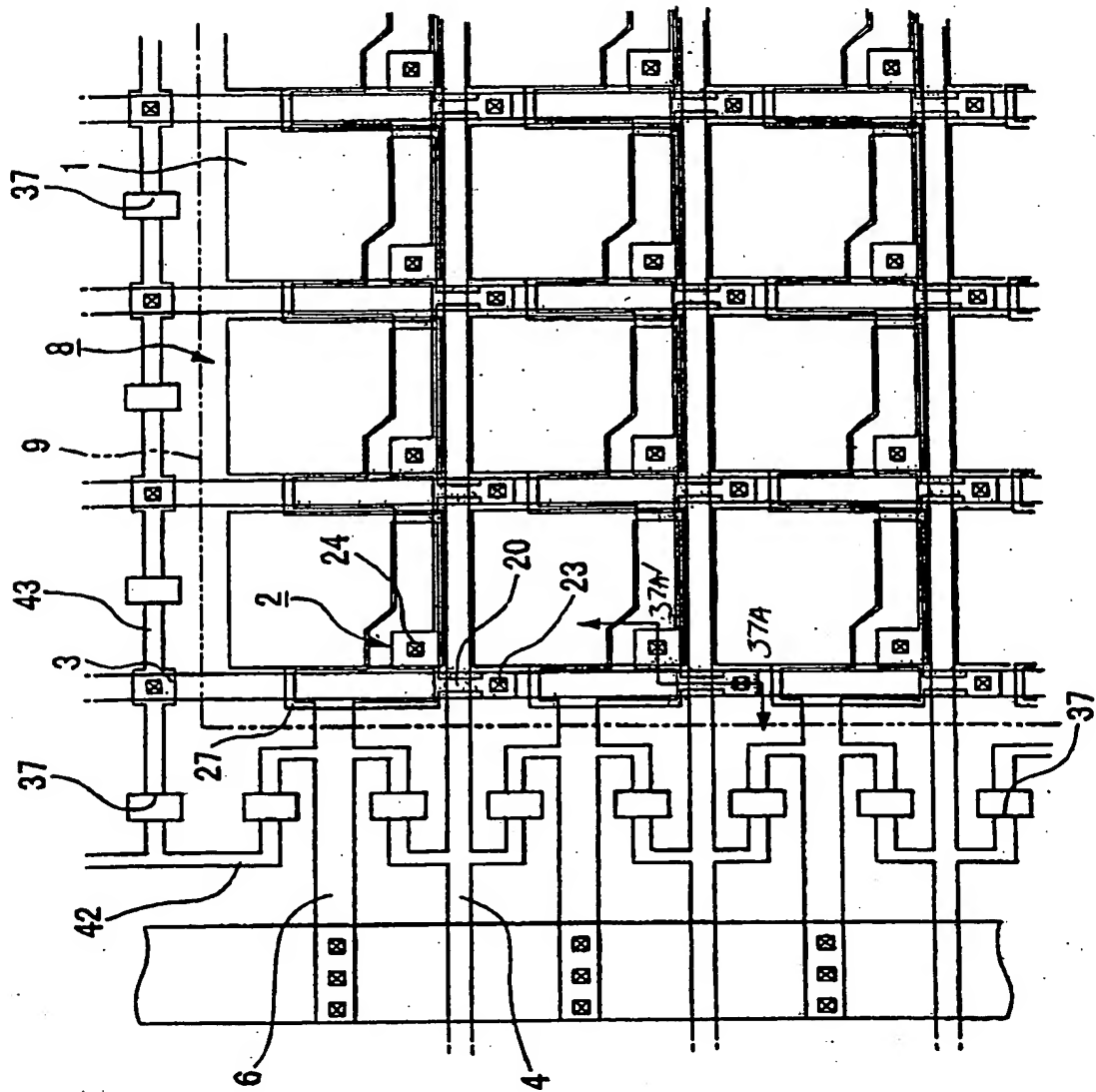


FIG. 34

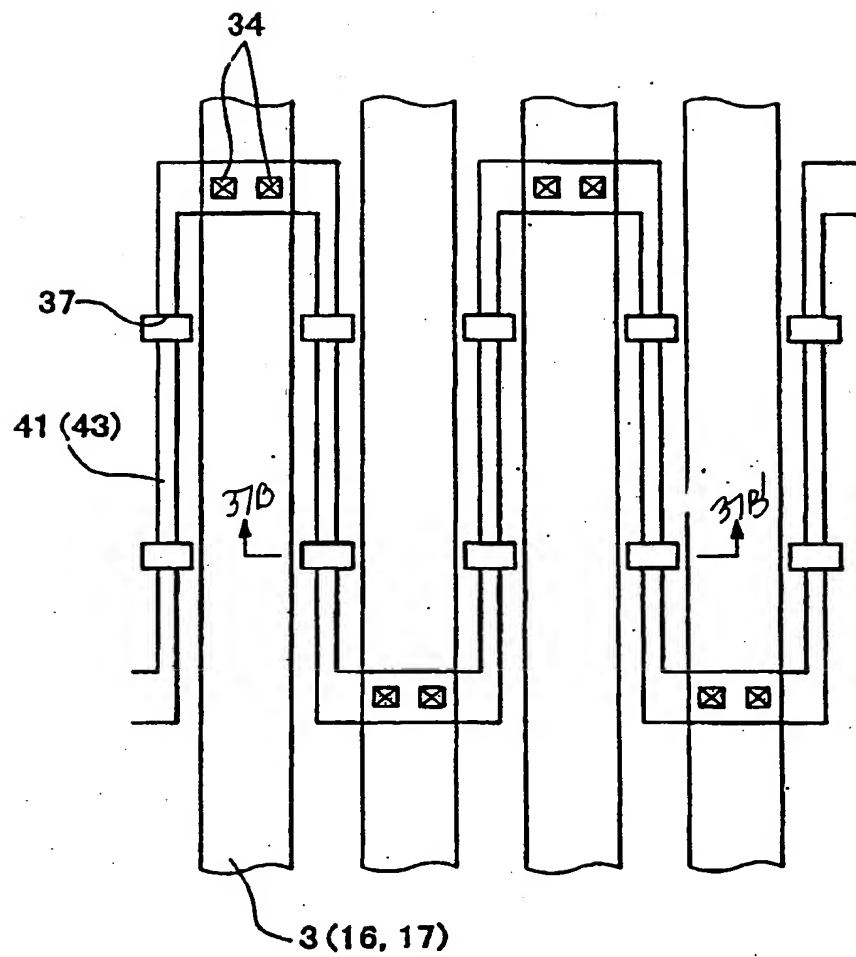


FIG. 35

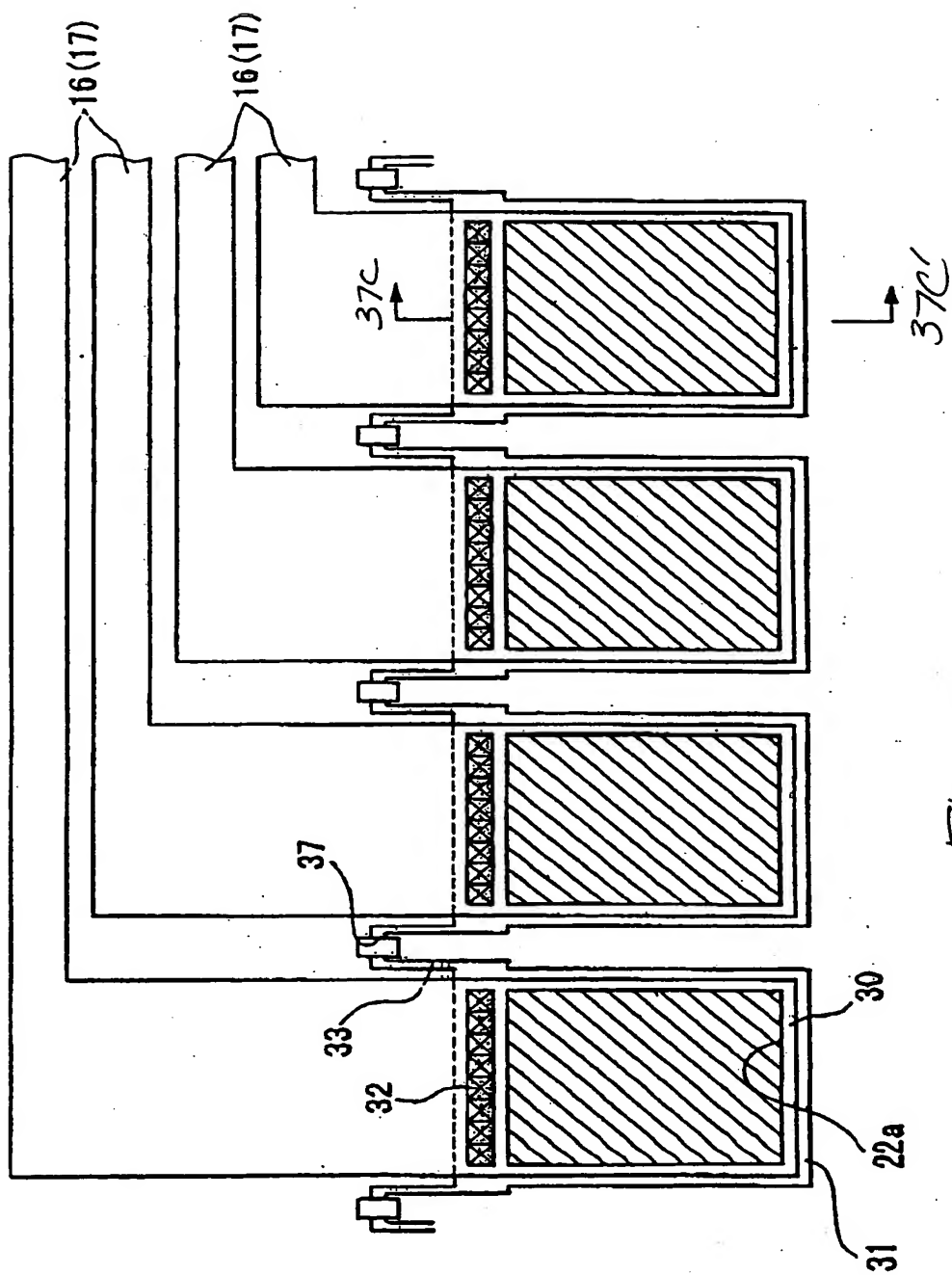


FIG. 36

<PIXEL TFT AREA> <ELECTROSTATIC MEASURE WIRING AREA> <TERMINAL AREA>

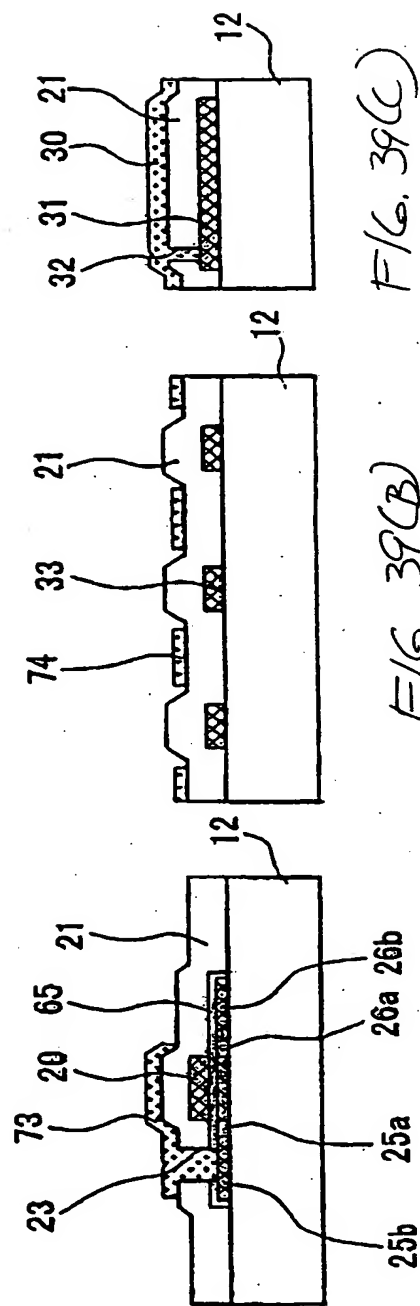
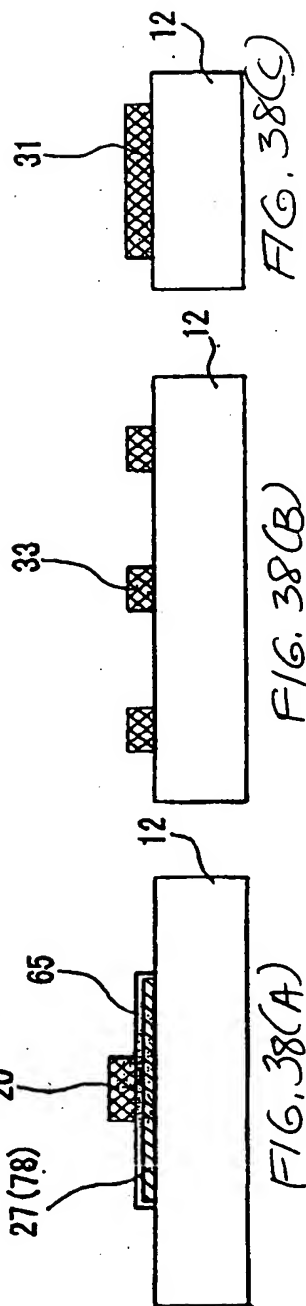
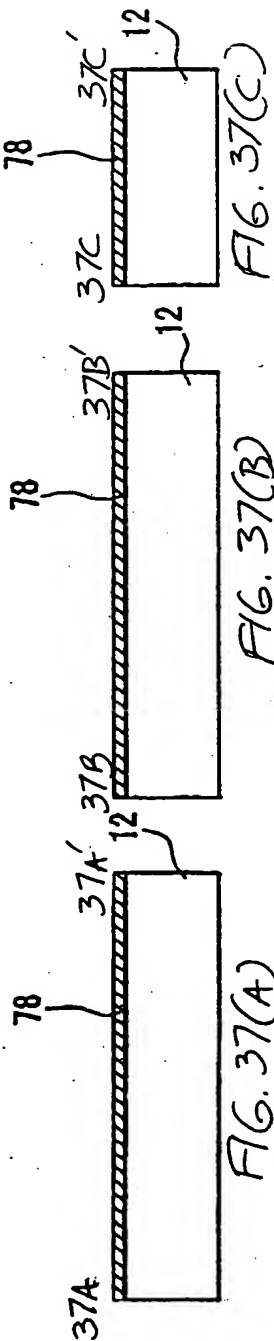


FIG. 39(A)

—
〈PIXEL TFT AREA〉 〈ELECTROSTATIC MEASURE WIRING AREA〉 〈TERMINAL AREA〉

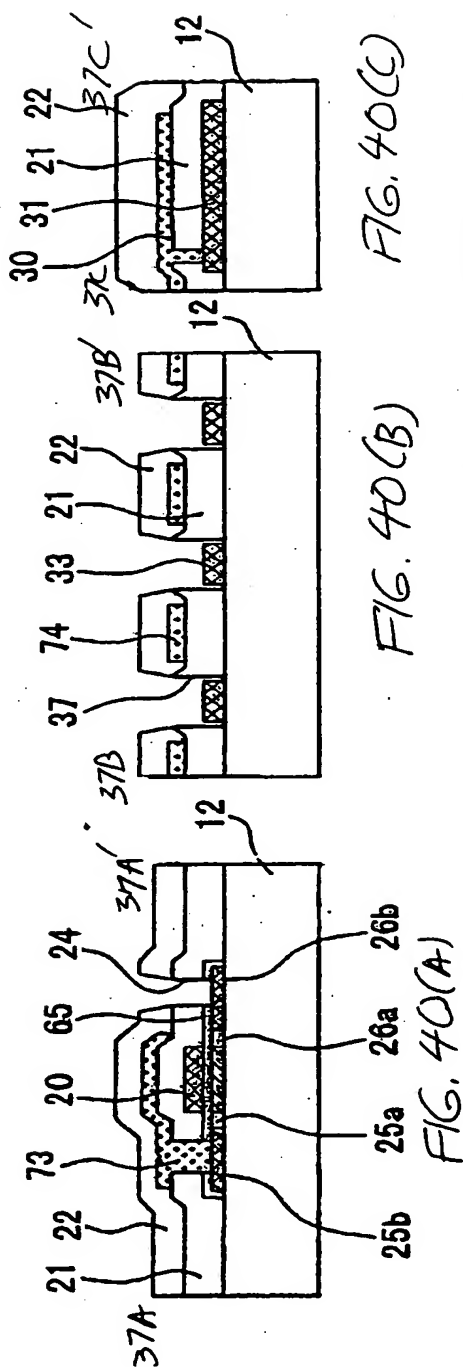


FIG. 40(B)

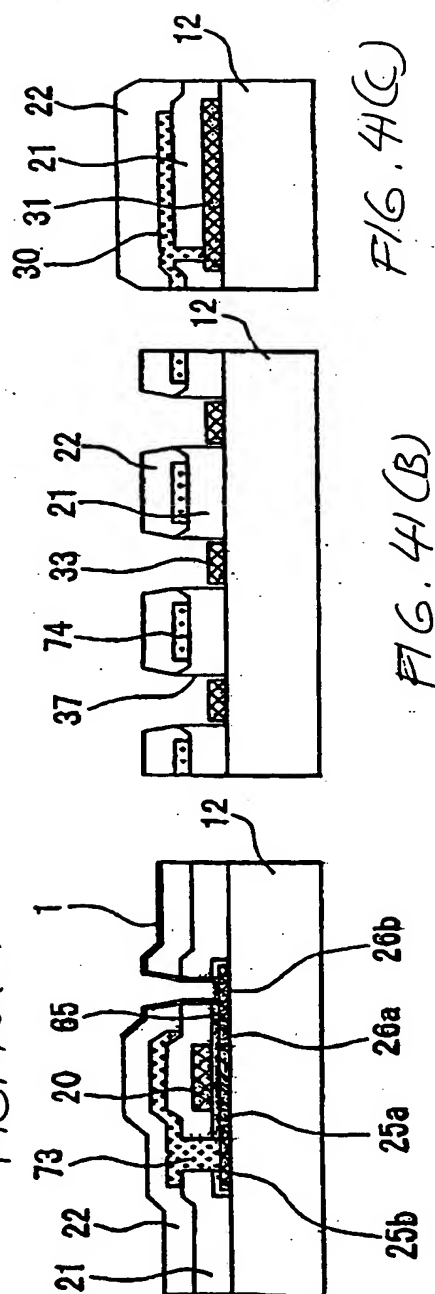


FIG. 41(C)

FIG. 41(B)

FIG. 41(A)

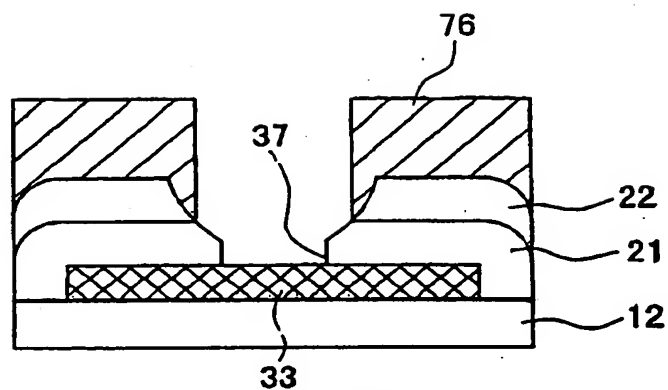


FIG. 44(A)

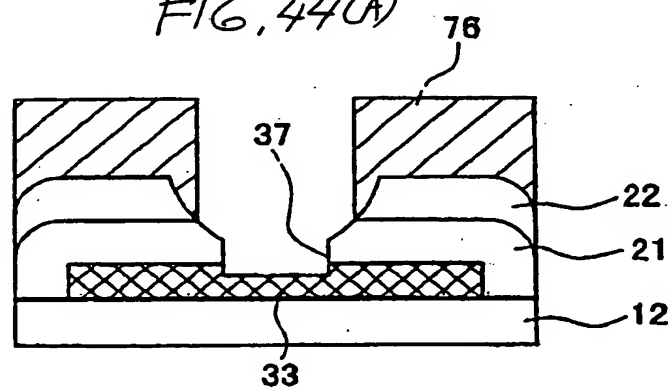


FIG. 44(B)

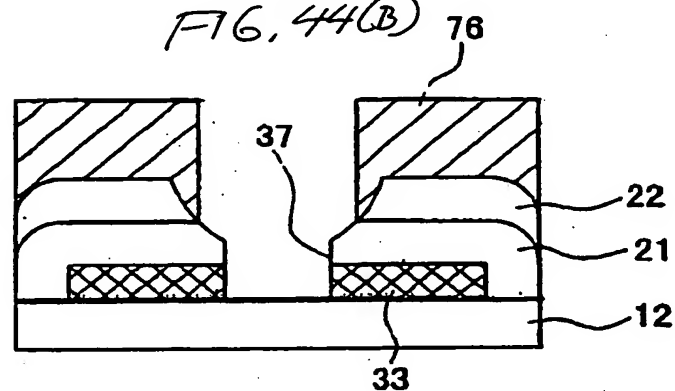


FIG. 44(C)